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AMENDMENT

(Amendment under the provision of Law Section 11)

To: Commissioner of the Patent Office

1. Identification of the International Application

PCT/JP2005/05183

2. Applicant

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4. Item to be Amended

Specification and Claims

5. Subject Matter of Amendment

(1) At line 22, page 5 of the specification, delete "elements)" and insert -- elements), which has a film thickness of 0.2 to 400 μm , --.

(2) At line 23, page 5 of the specification, insert -- on a substrate -- after "film".

(3) In page 6 of the specification, delete line 7 to line 10.

(4) At line 13, page 6 of the specification, delete "any one of".

(5) At line 13, page 6 of the specification, delete "itêms (1) to (3)" and insert -- item (1) or (2) --.

(6) At line 4, Claim 1, delete "elements)" and insert - elements), which has a film thickness of 0.2 to 400 μm , --.

(7) At line 5, Claim 1, insert -- on a base material -- after "film".

(8) Cancel Claim 3 now on file.

(9) At line 2, Claim 4, delete "any one of Claims 1 to 3" and insert -- Claim 1 or 2 --.

6. List of Attached Documents

(1) Pages 5 and 6 of the specification and Claims